Attorney Docket No. 0756-7209

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )
Shunpei YAMAZAKI et al. )
Serial No. 10/678,083 )
Filed: October 6, 2003 )
For: METHOD OF IRRADIATING LASER, )
LASER IRRADIATION SYSTEM, AND )
MANUFACTURING METHOD OF )
SEMICONDUCTOR DEVICE )

Group Art Unit: 2823

Examiner: Phillip Green

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 13, 2006.

Adelia M Stamps

**AMENDMENT**

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated March 13, 2006, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.